

2823

JFW



In re application of: Raffaele Zambrano  
 Serial No.: 09/191,743  
 Filed: November 13, 1998  
 For: IN-SITU DEPOSITION AND DOPING PROCESS  
 FOR POLYCRYSTALLINE SILICON LAYERS  
 AND THE RESULTING DEVICE

COMMISSIONER FOR PATENTS  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an amendment in the above-identified application.

- [ ] Small entity status of this application under 37 CFR 1.9 and 1.27 has been established by a verified statement previously submitted.  
 [ ] A verified statement to establish small entity status under 37 CFR 1.9 and 1.27 is enclosed.  
 [ ] A petition for extension of time is enclosed.  
 [ ] A notice of appeal is enclosed.  
 [X] No additional fee is required.

The fee has been calculated as shown below:

	(Col. 1)	(Col. 2)	(Col. 3)	SMALL ENTITY			OTHER THAN A SMALL ENTITY		
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST NO PREVIOUSLY PAID FOR	PRESENT EXTRA	ADDIT. RATE	FEE	OR	ADDIT. RATE	FEE	
TOTAL	17 MINUS	25 =	0	x 9	\$	OR	x 18	\$	
INDEP CLAIMS	2 MINUS	4 =	0	x 43	\$	OR	x 86	\$	
[ ] FIRST PRESENTATION OF MULTIPLE DEP. CLAIM				+145	\$	OR	+290	\$	
				TOTAL	\$	OR	TOTAL	\$ -0-	

- [ ] The Commissioner is hereby authorized to charge payment in the amount of \$\_\_\_\_\_ to cover the filing fee to Deposit Account No. 50-1556.  
 [ ] The Commissioner is hereby authorized to charge payment in the amount of \$\_\_\_\_\_ to cover the extension fee to Deposit Account No. 50-1556.  
 [ ] The Commissioner is hereby authorized to charge payment in the amount of \$\_\_\_\_\_ to cover the notice of appeal fee to Deposit Account No. 50-1556.  
 [X] The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 50-1556.  
 [X] Any filing fees under 37 CFR 1.16 for the presentation of extra claims.  
 [X] Any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

Stephen Bongini  
 Registration No. 40,917

Date: September 15, 2004

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PATENT  
97-CT-174

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
RAFFAELE ZAMBRANO	)	Group Art Unit: 2823
Serial No.: 09/191,743	)	
Confirmation No.: 8970	)	Examiner: M. Estrada
Filed: November 13, 1998	)	
For: IN-SITU DEPOSITION AND	)	
DOPING PROCESS FOR POLY-	)	
CRYSTALLINE SILICON LAYERS	)	
AND THE RESULTING DEVICE	)	
_____	)	

AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated June 15, 2004, in connection with the above-identified application, please enter and consider the following amendment and remarks.

I hereby certify that this correspondence is  
being deposited with the United States Postal  
Service with sufficient postage as first class  
mail in an envelope addressed to:  
Commissioner for Patents, P.O. Box 1450,

Alexandria, VA 22313-1450, on 9/15/04  
Date of Deposit

Stephen Bongini  
Applicant, Assignee, or Representative  
[Signature] 9/15/04  
Signature Dated